



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Menon et al. **GROUP:** 1756
SERIAL NO: 10/677,804 **EXAMINER:** John A. McPherson
FILED: October 2, 2003
FOR: SYSTEM AND METHOD FOR HOLOGRAPHIC FABRICATION AND
REPLICATION OF DIFFRACTIVE OPTICAL ELEMENTS FOR
MASKLESS LITHOGRAPHY

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CHANGE OF CORRESPONDENCE ADDRESS

Applicant's representative requests that the correspondence address for the above application be changed to:

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Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Meghan H. Carr
Meghan H. Carr
06/15/2006
Date